



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Mak, et al.

Serial No.: 09/885,609

Confirmation No.: 5337

Filed: June 20, 2001

For: System And Method To  
Form A Composite Film  
Stack Utilizing Sequential  
Deposition Techniques

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Group Art Unit: 2818

Examiner: Renee R. Berry

**CERTIFICATE OF MAILING**  
37 CFR 1.8

## **SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

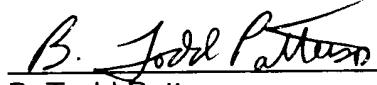
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The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

The Commissioner is hereby authorized to charge sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/APPM/5351/BTP.

Respectfully submitted,

  
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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. APPM/5351/CPI/L/B/ PJS	Serial No. 09/885,609
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Mak, et al.	Confirmation No.: 5337
(Use several sheets if necessary)		Filing Date June 20, 2002	Group 2818
Examiner    Renee R. Berry			

**U.S. Patent Documents**

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
	A1	6,481,945	11-19-2002	Hasper, et al.	414	217	06-04-1999
	A2	6,478,872	11-12-2002	Chae, et al.	117	88	12-20-1999
	A3	6,447,607	09-10-2002	Soininen, et al.	117	200	12-27-2000
	A4	6,231,672	05-15-2001	Choi, et al.	118	715	05-18-1999
	A5	6,183,563	02-06-2001	Choi, et al.	118	715	05-18-1999
	A6	2002/0134307	09-26-2002	Choi	118	715	11-30-2000
	A7	2002/0108570	08-15-2002	Lindfors	118	715	04-16-2001
	A8	2002/0094689	07-18-2002	Park	438	694	03-07-2002
	A9	2002/0092471	07-18-2002	Kang, et al.	118	715	01-16-2002
	A10	2002/0086106	07-04-2002	Park, et al.	427	248.1	11-07-2001
	A11	2002/0041931	04-11-2002	Suntola, et al.	427	255.28	05-14-2001
	A12	2002/0007790	01-24-2002	Park	118	715	05-03-2001
	A13	2002/0000196	01-03-2002	Park	118	715	05-03-2001

**Foreign Patent Documents**

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
	B1	EP 1 167 569 ✓	01-02-2002	EP	C23C	16/455	RE	X
	B2	WO 02/08488 ✓	01-31-2002	WIPO	C23C	16/44	RE	X
	B3	WO 01/17692 ✓	03-15-2001	WIPO	B05C	11/00	RE	X
	B4	WO 99/65064 ✓	12-16-1999	WIPO	H01L	21/00	RE	X

**OTHER ART**

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	

Examiner	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

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	A14	2002/0052097	05-02-2002	Park	438	507	05-03-2001
	A15	2001/0054377	12-27-2001	Lindfors, et al.	117	104	04-16-2001
	A16	2001/0042523	11-22-2001	Kesala	122	6.6	05-14-2001
	A17	2001/0014371	08-16-2001	Kilpi	427	255.28	12-27-2000
	A18	2001/0013312	08-16-2001	Soininen, et al.	117	86	12-27-2000
	A19	2001/0009140	07-26-2001	Bondestam, et al.	118	725	01-25-2001
	A20						10 2000 MAIL ROOM
	A21						MAR 11 2000
	A22						RECEIVED
	A23						U.S. PATENT & TRADEMARK OFFICE
	A24						SEARCHED
	A25						INDEXED
	A26						FILED

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	B5							
	B6							
	B7							

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